

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/574,316	KIM, et al.	
	Examiner	Art Unit	
	Calvin Lee	2892	7093-006

## SEARCHED

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
438	82	10/27/08	CL
257	186	#	#